

Draft
 Minutes of ASC OP Meeting
 Monday, January 26, 2009, 1:30 p.m. – 3:00 p.m.
 Fairmont Hotel, California Room
 170 South Market Street, San Jose, CA 95113

Present	Participants (6 of 22+ 1 alt.)	Representing
<input checked="" type="checkbox"/>	Committee Members	
<input type="checkbox"/>	David Aikens	Savvy Optics
<input type="checkbox"/>	Sam Bailey (alternate)	Davidson Optronics, Inc.
<input type="checkbox"/>	Gordon Boulton	JDS Uniphase Corporation
<input type="checkbox"/>	Andrei Brunfeld	Xyratex
<input checked="" type="checkbox"/>	Walter Czajkowski	APOMA (Edmund Optics)
<input type="checkbox"/>	Jessica E. DeGroote Nelson	Optimax Systems, Inc.
<input type="checkbox"/>	Frank Dombrowski	Gage-Line Technology, Inc.
<input checked="" type="checkbox"/>	Marla Dowell	IEEE/LEOS
<input checked="" type="checkbox"/>	Marla Dowell	NIST
<input type="checkbox"/>	Lincoln Endelman	SPIE (Endelman Enterprises)
<input type="checkbox"/>	Charles Gaugh	Davidson Optronics, Inc.
<input type="checkbox"/>	Rudolf Hartmann	Honorary
<input checked="" type="checkbox"/>	Hal Johnson	Harold Johnson Optical
<input type="checkbox"/>	Allen Krisiloff	Triptar Lens Co., Inc.
<input type="checkbox"/>	Wayne R. McKinney	Lawrence Berkeley National Lab
<input type="checkbox"/>	Jonathan McGuire	Northrop Grumman Laser Systems
<input type="checkbox"/>	Bruce Netherton	Lockheed Martin Coherent Technologies
<input checked="" type="checkbox"/>	Rick Plympton (Alternate)	Optimax Systems, Inc.
<input type="checkbox"/>	Kathleen Richardson	School of Materials Science & Eng., Clemson
<input checked="" type="checkbox"/>	William E. Royall	Honorary
<input type="checkbox"/>	Peter Takacs	Brookhaven National Lab.
<input type="checkbox"/>	Trey Turner	Research Electro-Optics, Inc.
<input type="checkbox"/>	Steven VanKerkhove	Corning Tropel
<input type="checkbox"/>	Ray Williamson	Ray Williamson Consulting
Observers (1)		
<input checked="" type="checkbox"/>	Gene Kohlenberg	OEOSC

Welcome and Introductions

H. Johnson opened the meeting at 1:40 p.m.

Adoption of Agenda

R. Plympton moved that the draft agenda be approved; M. Dowell seconded the motion which passed unanimously.

Approval of the Sunday, October 20, 2008 ASC OP Meeting Draft Minutes

A. Krisiloff moved that the draft minutes be approved. M. Dowell seconded the motion; the motion passed unanimously.

Reports

Performance Based Optical-Surface Imperfection Standard

A. Krisiloff reviewed status of OP1.002, saying that it is well on way to approval. Work item to be developed into a draft by next meeting. A. Krisiloff is the project leader. Comments will be collected about the working draft.

Wavefront Specification Project

A. Krisiloff reported about OP1.004 and OP1.005. P. Takacs was conducting research of nomenclature in other standards. There is an early draft of OP1.005. There was a discussion concerning the half-dozen issues that C, Evans had raised in the meeting.

ISO Standards Development Projects

M. Dowell reported on the adoption of ISO 10110 series of standards as American National Standard (ANS). The Task Force approved ISO 10110-1, ISO 10110-12, had discussions on -5, 14999-4, and proposed a strategy for releasing other ISO standards as ANS.

One-Hour Short Overview of Scratch and Dig Standards

A. Krisiloff opened up new objectives of the short version overview. It would include more advertising for the longer scratch and dig class. Comments will be compiled into another draft. The OP members offered several ideas as to the purpose of the over view.

W. Czajkowski said that comments were made about the cost of manufacture if scratch and dig process were improved.

M. Dowell asked if this overview could be given during seminar time at the Photonics West manufacturing display. TF members were asked to provide anecdotes about how expensive scratch and dig issues are.

Other Business

Numbering System for ASC OP Standards

This subject was raised because of the need to add US adopted ISO standards to the stable of OP standards. The first one to be considered is ISO 10110. D. Aikens had suggested to make the US number similar to the ISO number, so it could be should be labeled 10.110. However, this does not fit into the current numbering philosophy. Since the standard would fall under fundamental standards, in the OP system the document would be numbered OP1.110. W. Royall said that he would want to see the US version appear in a computer search along with the ISO version. He would be searching for 10110. The Secretary said that since the US version of the ISO standard has some differences, the standard cannot be labeled ANSI/ISO 10110. It has to have a unique OP number followed by the ISO number. Therefore the US version of ISO 10110-1 would have to be labeled, “ANSI/OEOSC OP1.110-1:20XX (ISO 10110-1:2004 MOD).” The “MOD” term is applied to confirm that the document has been modified for the US version. The Secretary continued that when one searches for 10110-1, the US version should also appear, since 10110-1 is part of its total designation. No version of the OP number, whether it started with “1.” or “10.” would, by itself, cause the US version to appear in a search for 10110. M. Dowell moved that OP resolve to keep the current OP numbering system so that OP1.110 would be adopted. A. Krisiloff seconded the motion. The motion carried unanimously. Since there was not a quorum at this meeting, M. Dowell moved that there be a vote by correspondence to confirm this decision. W. Czajkowski seconded the motion. The motion carried unanimously.

Glass Course.

A. Krisiloff had showed an expanded comparison of glass standards through the ages. A revised OP3.001, “Optical Glass” needs to be completed, and the glass course will be completed simultaneously. This project is currently a lower priority than other standards under development. A. Mistry asked why the need to provide such a course. A. Krisiloff replied that it helps with the OEOSC revenue stream. It could also be a source of publicity for OEOSC’s standards development program.

Time and Place for Next OP Meeting

A. Krisiloff moved that the OP meeting be held during the 2010 SPIE’s Photonics West in San Francisco, CA. R. Plympton seconded the motion, which carried unanimously.

Adjourn

Since there was no further business to come before the committee, M. Dowell moved that the meeting be adjourned. W. Czajkowski seconded the motion. The meeting was adjourned at 2:10 p.m.